



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Inventor: David Russell Evans

Serial No.: 09/270,606

Filed: March 17, 1999

Title: METHOD FOR  
MODIFICATION OF  
POLISHING  
PATTERN  
DEPENDENCE IN  
CHEMICAL  
MECHANICAL  
POLISHING

PATENT APPLICATION

Attorney Docket No.  
SLA 587 (SMT 335)

Group No. 1765

Examiner: M. Anderson

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Box Fee Amendment  
Assistant Commissioner for Patents  
Washington, DC 20231

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

This Response is an amendment responsive to an Office  
Action dated July 13, 2001.

Please amend the above-identified application as follows: